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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Yuka HAYAMI et al.**

Group Art Unit: **1765**

Serial No.: **10/695,874**

Examiner: **Kin Chan Chen**

Filed: **October 30, 2003**

Confirmation Number: **6663**

For: **SEMICONDUCTOR DEVICE FABRICATION METHOD**

Attorney Docket Number: **032070**

Customer Number: **38834**

RESPONSE

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Date: August 10, 2005

Sir:

This paper is filed in response to the Office Action dated July 22, 2005.

Remarks/Arguments begin on page 2 of this paper.